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684.2935

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Examiner: Unassigned
TOSHIYUKI YOSHIHARA

Group Art Unit: 2873
Application No.: 09/438,491

Filed: November 12, 1999

For: ABERRATION CORRECTING
OPTICAL SYSTEM

March 9, 2000

The Assistant Commissioner for Patents Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

Sir:

To comply with the duty of disclosure under 37 CFR 1.56 and in accordance with the practice under 37 CFR 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed PTO-1449 Form. Copies of the listed documents are also enclosed.

(1) Japanese Laid-Open patent application No.

1-121816 is discussed on page 3 of the subject specification and relates to a solid-state image pickup device.

- (2) Japanese Laid-Open patent application No.

 10-27743 is also discussed on page 3 of the subject specification and relates to a projection aligner, a device manufacturing method and an aberration correcting optical system.
- (3) Japanese Laid-Open patent application No.
 7-183190 is discussed on page 6 of the subject specification and relates to a projection aligner.

Applicant requests that the Examiner consider the cited information and return an initialed copy of the enclosed PTO-1449 Form indicating that such information has been considered.

Applicant's undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should be directed to our address listed below.

Respectfully submitted,

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